

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention

MICROELECTROMECHANICAL SYSTEM BASED SENSORS,
SENSOR ARRAYS, SENSING SYSTEMS, SENSING METHODS
AND METHODS OF FABRICATION

Application Number :

Confirmation Number:

First Named Applicant: Ping MEI

Attorney Docket Number: 115252

Art Unit:

Examiner:

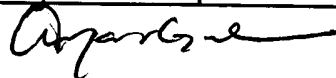
Search string: (6534249 or 6504643 or 6439898 or 6411427 or 6392524 or 6361331 or 6339289
or 6213789 or 6264477 or 6292208 or 6290510 or 6184699 or 6184065 or 5944537
or 5914218 or 5848685).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
2A	1	6534249	2003-03-18	FORK et al.			
	2	6504643	2003-01-07	PEETERS et al.			
	3	6439898	2002-08-27	CHUA et al.			
	4	6411427	2002-06-25	PEETERS et al.			
	5	6392524	2002-05-21	BIEGELSEN et al.			
	6	6361331	2002-03-26	FORK et al.			
	7	6339289	2002-01-15	FORK			
	8	6213789	2001-04-10	CHUA et al.			
	9	6264477	2001-07-24	SMITH et al.			
	10	6292208	2001-09-18	LOFHUS et al.			
	11	6290510	2001-09-18	FORK et al.			
	12	6184699	2001-02-06	SMITH et al.			
	13	6184065	2001-02-06	SMITH et al.			
	14	5944537	1999-08-01	SMITH et al.			
	15	5914218	1999-06-22	SMITH et al.			
	16	5848685	1998-12-15	SMITH et al.			

Signature



4/30/04

Examiner Name

Date